

Single-Photon Time-of-Flight Sensors for Spacecraft Navigation and Landing in CMOS Technologies

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Section V.C: Electronic Nanodevices and Technology Trends

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Outline

- Operation Principle of Geiger-mode APD (SPAD)
- Implementation of CMOS SPADs
- Single-Photon Detectors at FBK: CMOS and Full Custom technologies
- 3D ranging/imaging for space applications
- SPAD-based TOF Sensor Architecture
- Experimental results
- Conclusions

Acknowledgments

- All my colleagues: IRIS-FBK Team
- Special thanks to: Matteo Perenzoni
- CSEM team (V. Mitev, J. Haesler, C. Pache, T. Herr, A. Pollini)
- European Space Agency
- *Sensor details presented at ISSCC'16 , 1-4 Feb., San Francisco, USA*

Photodiode, APD, SPAD

- SPAD = photodiode biased beyond its breakdown voltage (Geiger mode)

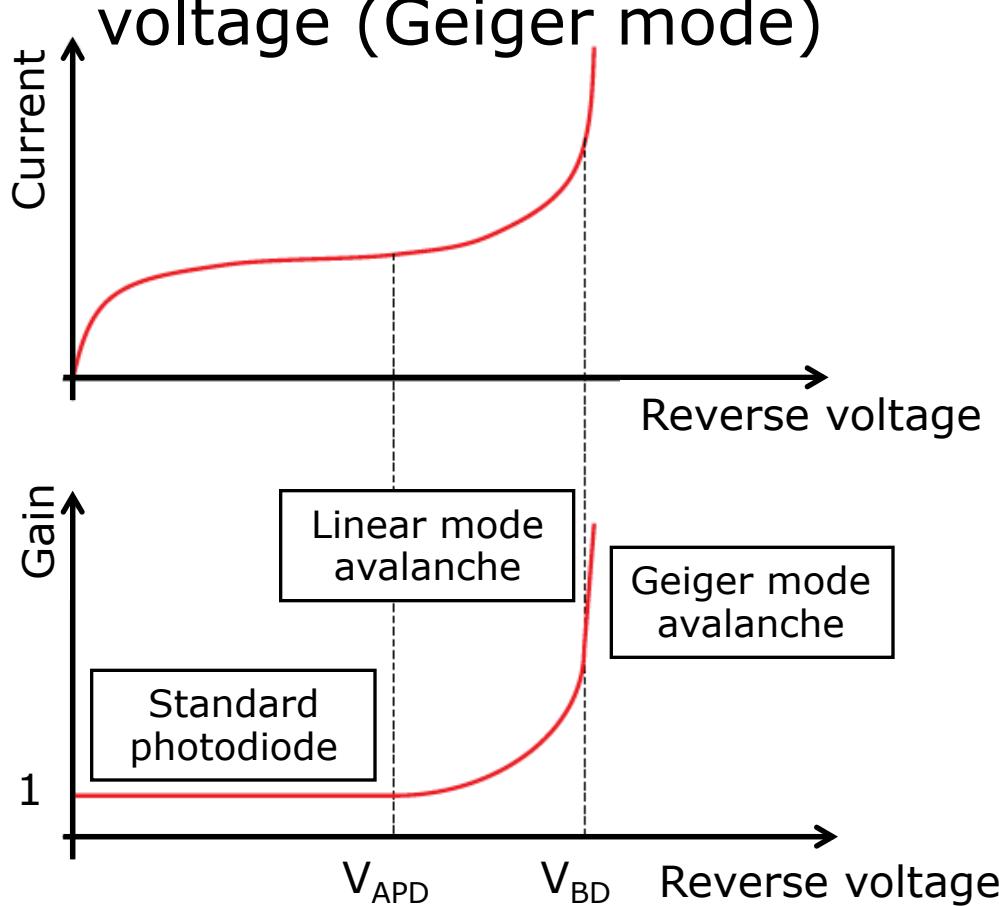
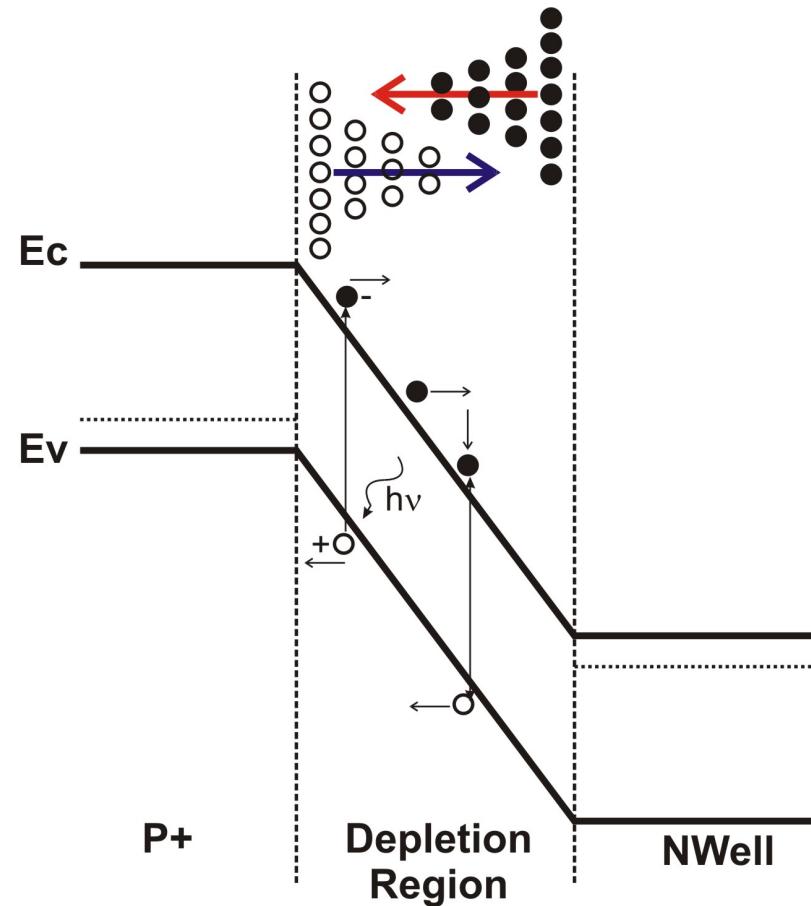


Photo-multiplication effect allows for
SINGLE PHOTON DETECTION

Avalanche and Breakdown

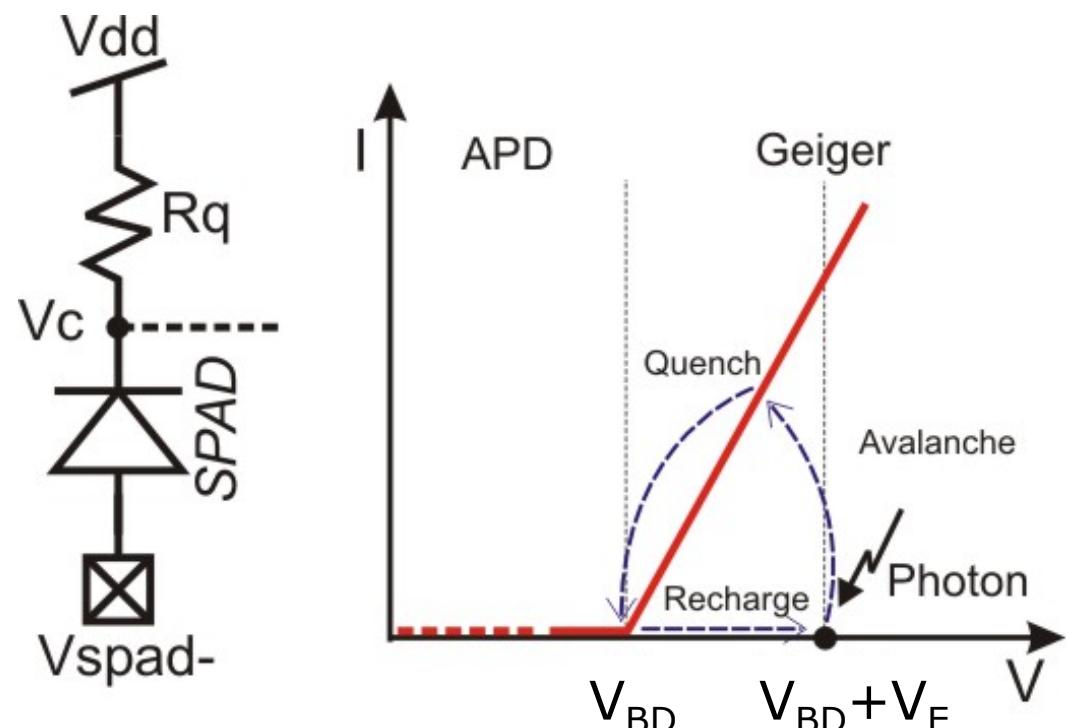
- High electric field within depletion region needed to reach breakdown



SPAD Operation

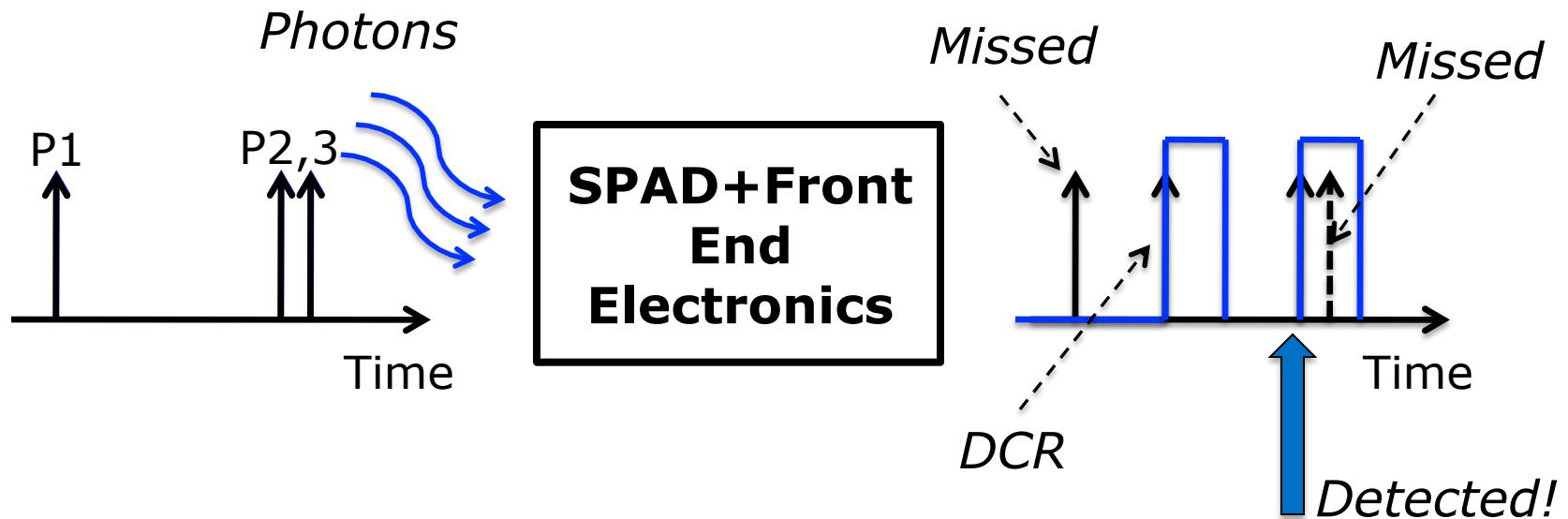
Operation Loop:

- 1. Entering the Geiger region at $V_{BD} + V_E$ (meta-stable point)
- 2. Avalanche
- 3. Quenching
- 4. Recharging to 1



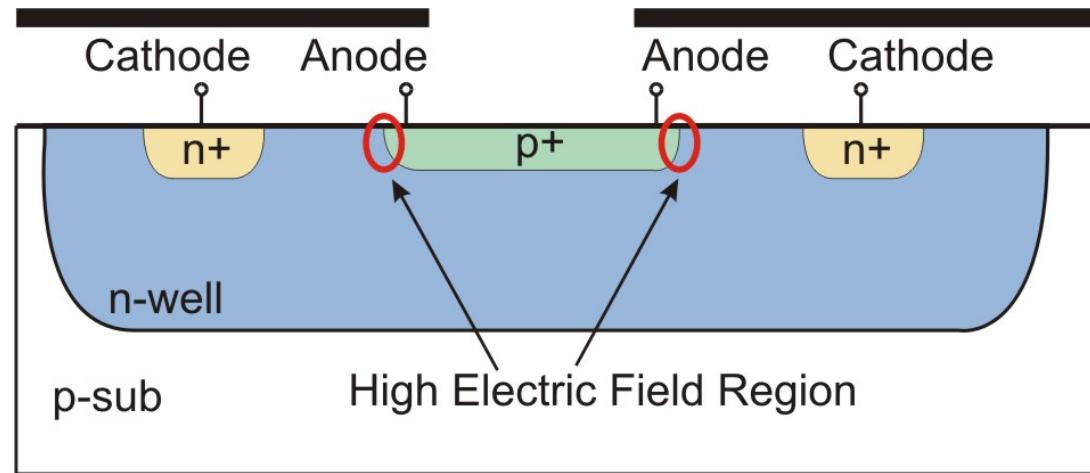
V_E : Excess bias voltage

SPAD High Level Behavior

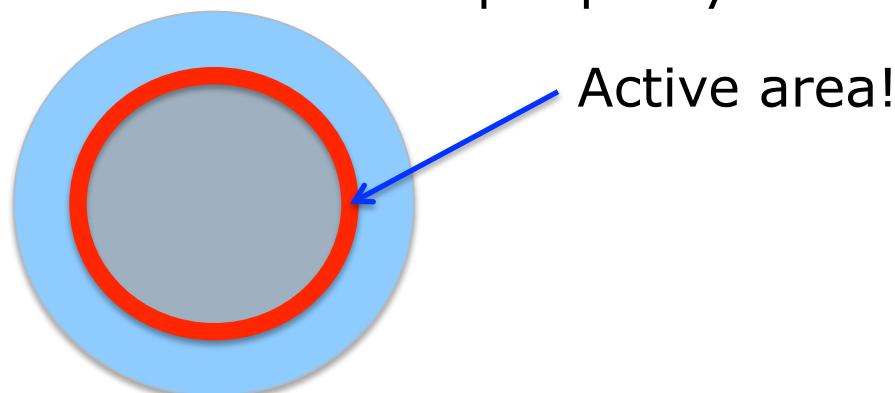


- Detected photons generate digital pulses
- Not all the photons are detected!
- Pulses are generated also in dark condition (DCR noise)
- Jitter noise between detected photon and digital output

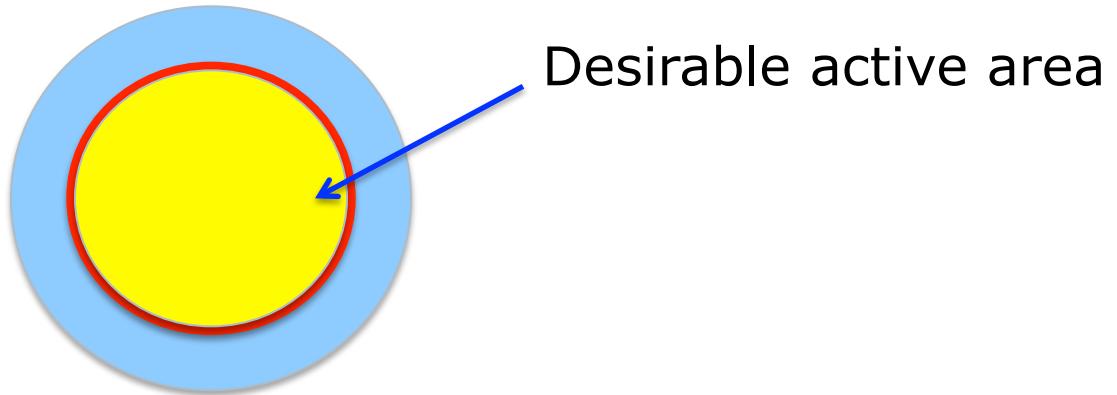
SPAD with a simple *pn* Junction?



- At the edges (shallow junctions) high electric fields
- Premature breakdown at the sensor periphery



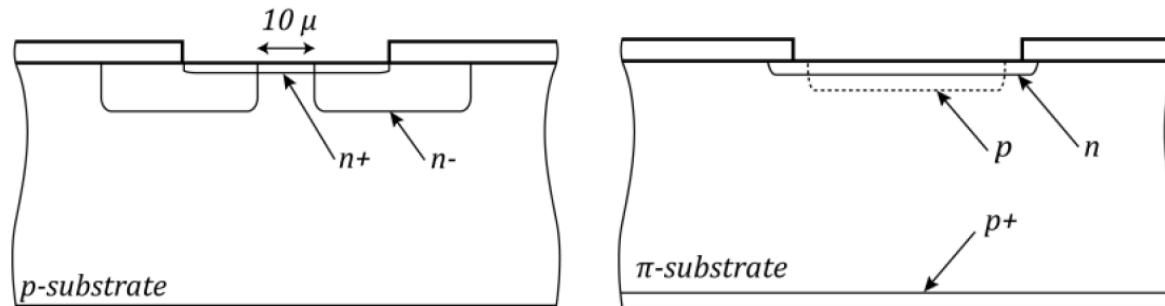
SPAD with a simple *pn* Junction?



- Guard-ring structure is needed to prevent breakdown at the periphery while keeping the avalanche region confined in the planar area

SPADs out of the Labs (Eventually!)

- SPAD known since 60's (!)

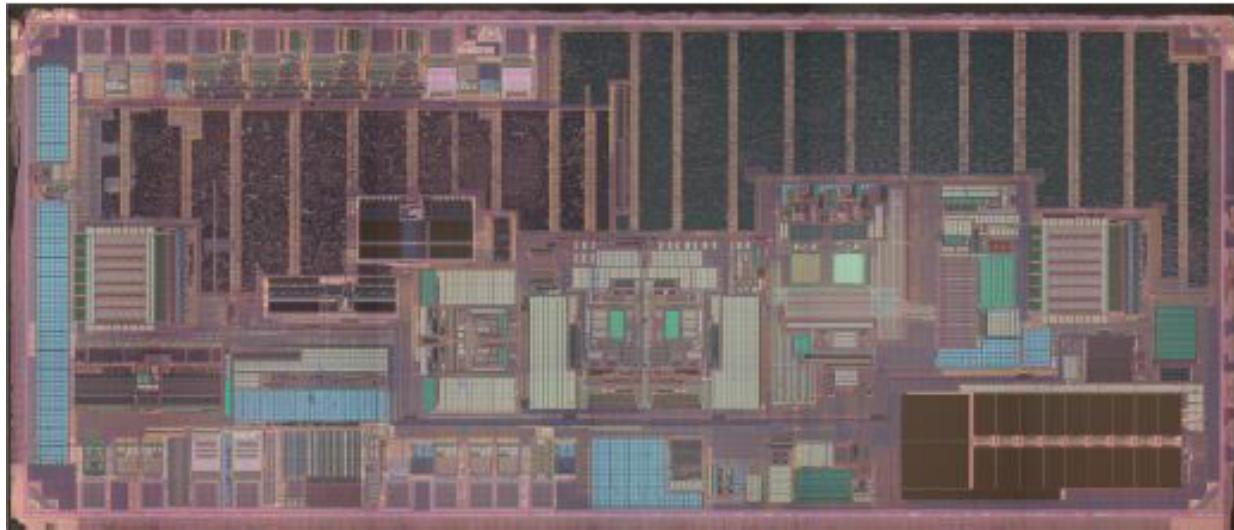


[1] R. J. McIntyre, *Theory of Microplasma Instability in Silicon*, J. of Applied Physics, pp. 983-995, 1961.
[2] R. H. Hertz, *Model for the Electrical Behavior of a Microplasma*, J. of Applied Physics, pp. 1370-1376, 1964.

- First CMOS implementations about fifteen years ago
- CMOS SPADs entered the market in 2012-2013

From high-end applications to consumer

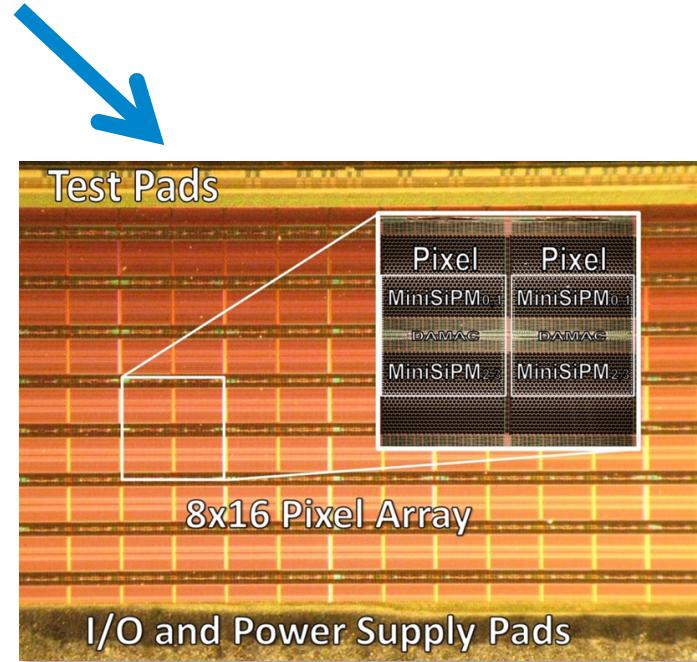
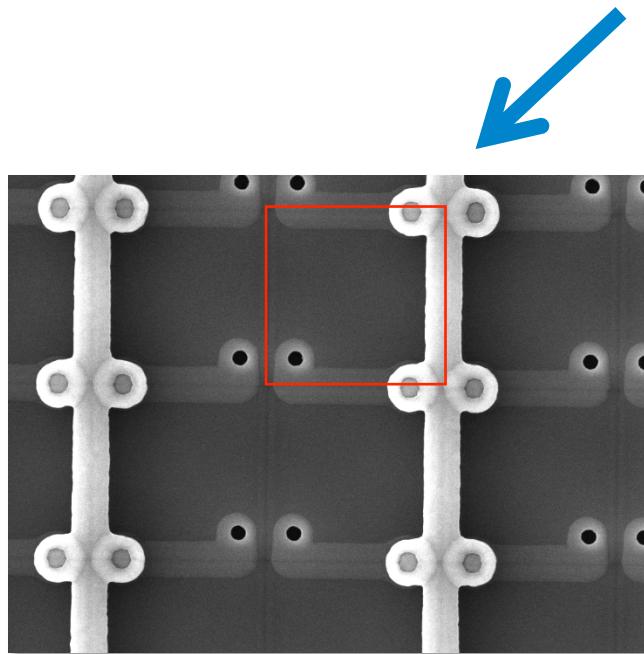
- STM SPAD-based TOF Proximity Sensor



@Chipworks (<http://ww2.chipworks.com/e/4202/6180-Time-of-Flight-Sensor-pdf/hwvfs/713665047>)

Single-Photon Detectors at FBK

Single-Photon Avalanche Diodes



Custom technology (FBK process):

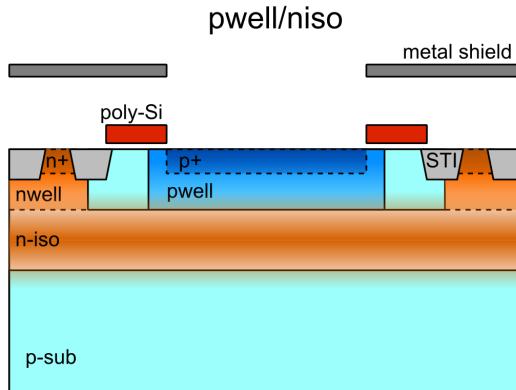
- high efficiency
- low noise
- high flexibility

Standard CMOS technology:

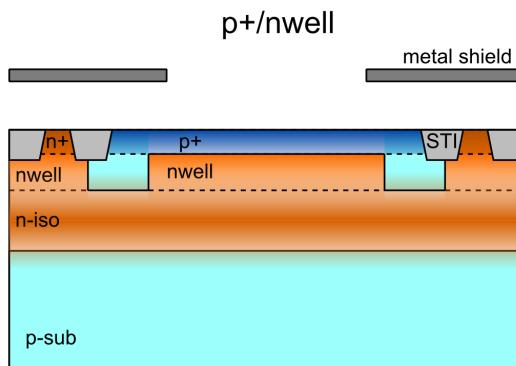
- smart architecture
- high-level integration

FBK CMOS SPAD in LFoundry 150nm

- First testchip (Langshut), 2010/2011: two SPADs, published at ESSDERC 2011



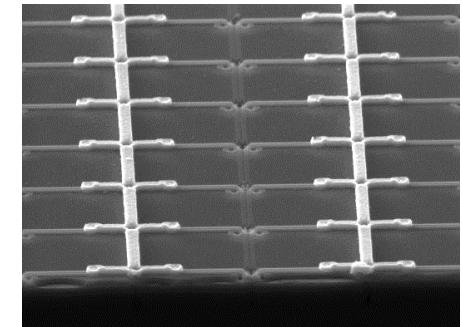
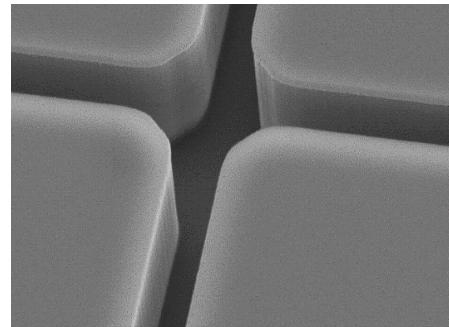
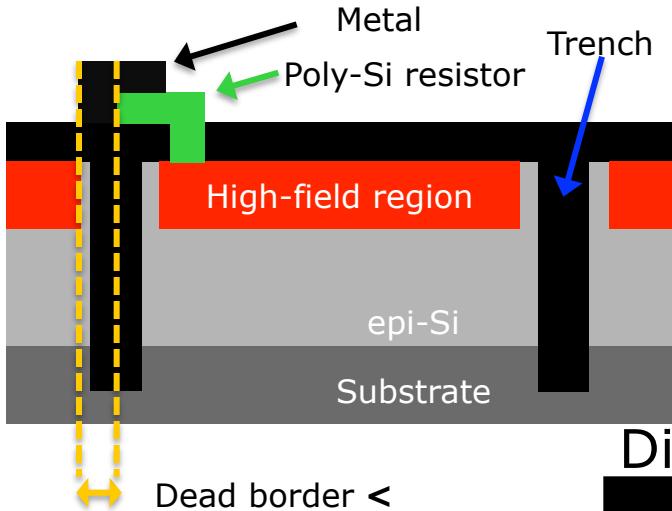
- Deep junction $> 0.5\mu\text{m}$
- Virtual guard ring
- Graded doping profiles



- Shallow junction $\sim 0.2\mu\text{m}$
- p-sub low-doped guard ring
- Steep p+ doping profile

Full Custom Technology: FBK SiPM

- Specialized process offers superior performance: DCR<200kHz/mm²



Different cells...

Cell pitch	Fill factor
15 μm	62 %
20 μm	66 %
25 μm	73 %
30 μm	77 %
35 μm	81 %
40 μm	83 %

Different SiPM layouts

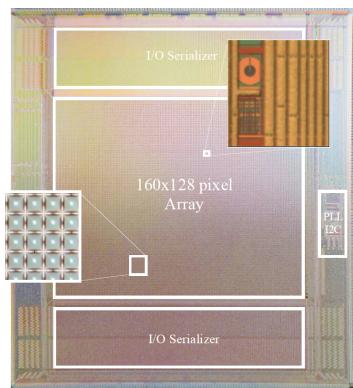
Active area	Cell pitch
1x1 mm ²	15 / 20 / 25 / 30 μm
Coming soon	
1x1 mm ²	35 / 40 μm
4x4 mm ²	30 / 35 / 40 μm
6x6 mm ²	30 μm

[28] A. Ferri et Al., NSS'15

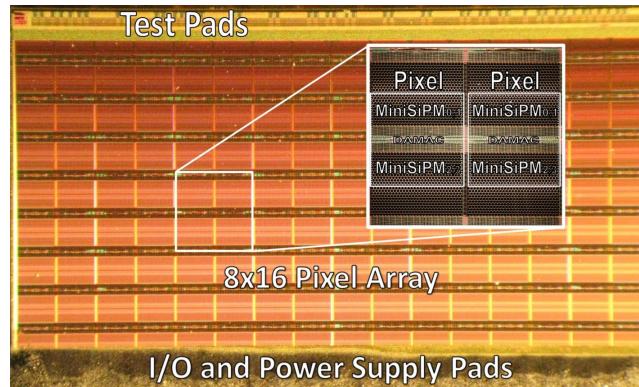
CMOS SPAD Sensors at FBK

- Developments originally driven by Biomedical applications
- Several different 'families' of sensors developed
- Three examples shown here:

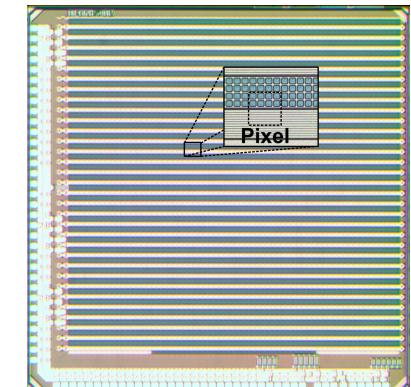
Lifetime Imaging



Positron Emission Tomography



3D Imaging



MEGAFRAME FP7-Project
www.megaframe.eu
Single SPAD + TDC
[Veerappan, ISSCC 2011]

SPADnet FP7-Project
www.spadnet.eu
D-SiPM + TDCs
[Braga, ISSCC 2013]

MILA ESA-Project
iris.fbk.eu/projects/mila
D-SiPM + TDC
[Perenzoni, ISSCC 2016]

Landing in Space

- Apollo 11 mission on the Moon
- Mars Space Laboratory on Mars
- Rosetta mission on comet 67P/C-G

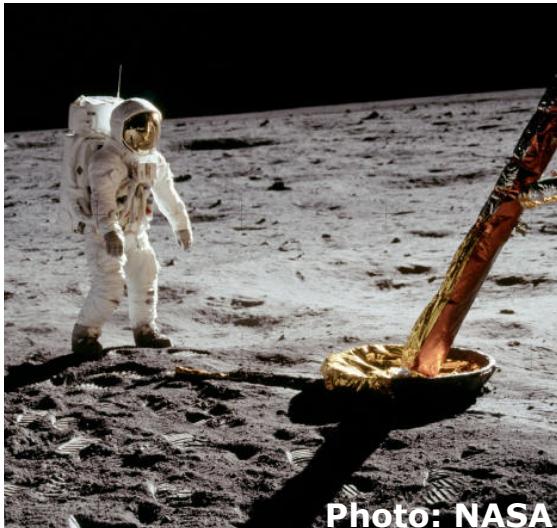


Photo: NASA

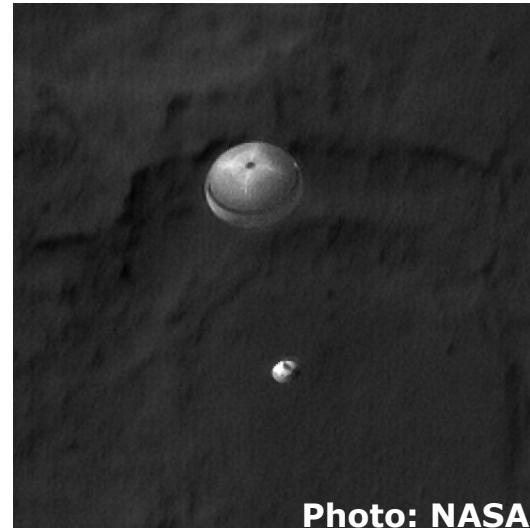


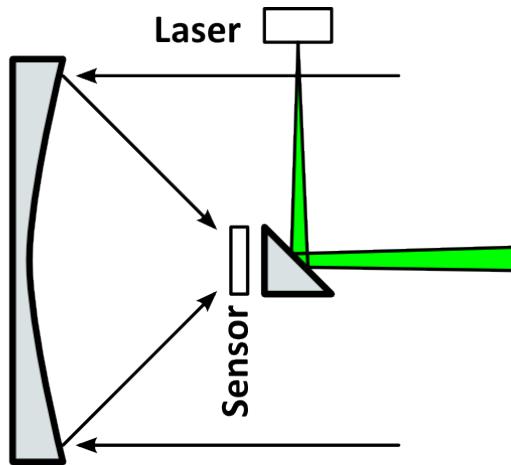
Photo: NASA



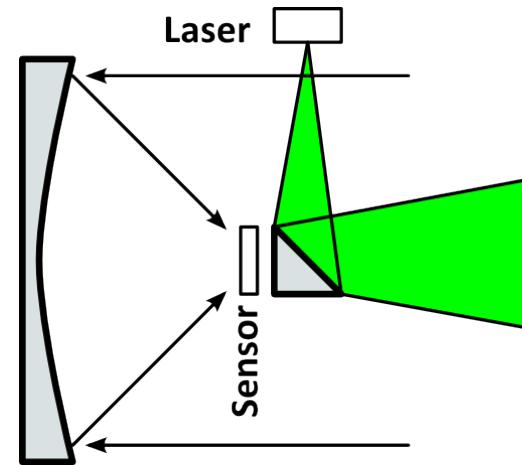
Photo: ESA

Long Measurement Range

Altimeter



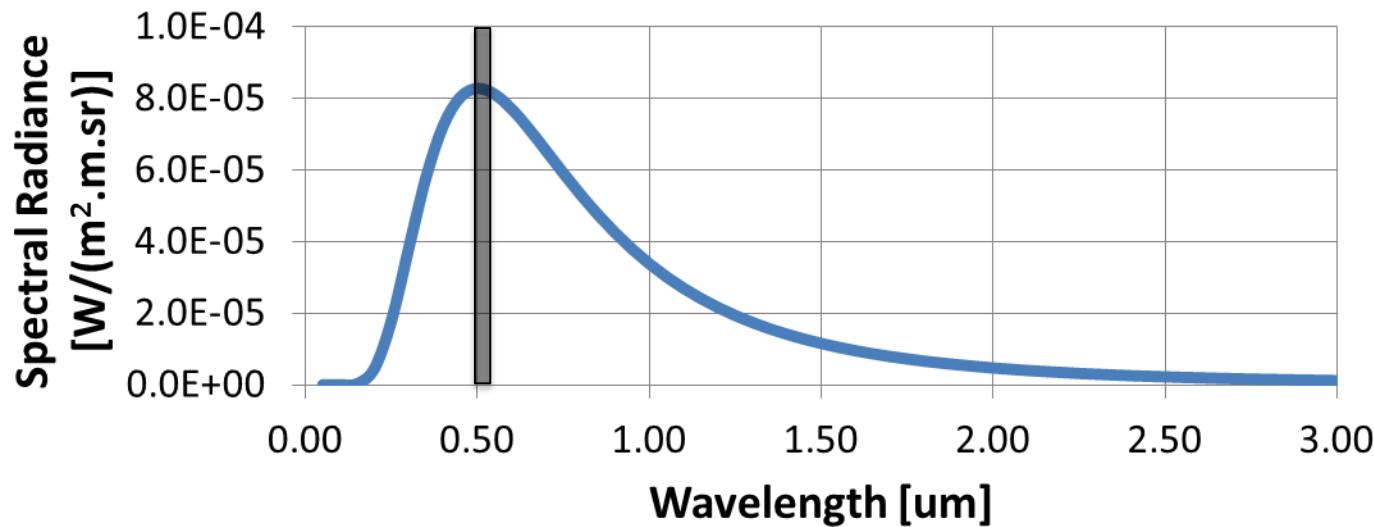
Imaging



<input type="checkbox"/> Mode:	100m-6km	30m-300m
<input type="checkbox"/> Max ToF:	40µs	2µs
<input type="checkbox"/> Precision:	1m (6.6ns)	10cm (660ps)

Wide DR and long light time-of-flight

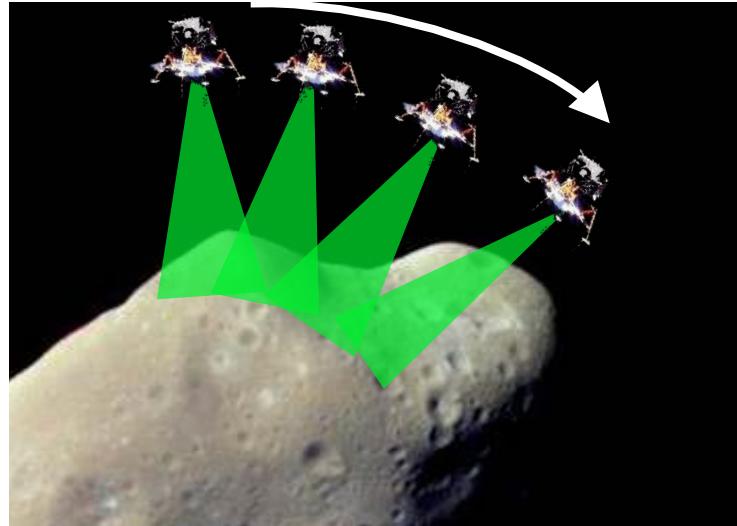
Immunity to background light



- With targeted pixel size and FF:
 - 100 Mph/s (detected)
- 5nm filter
Albedo <0.4
Sun angle 30°*

High Background Rejection

Acquisition speed

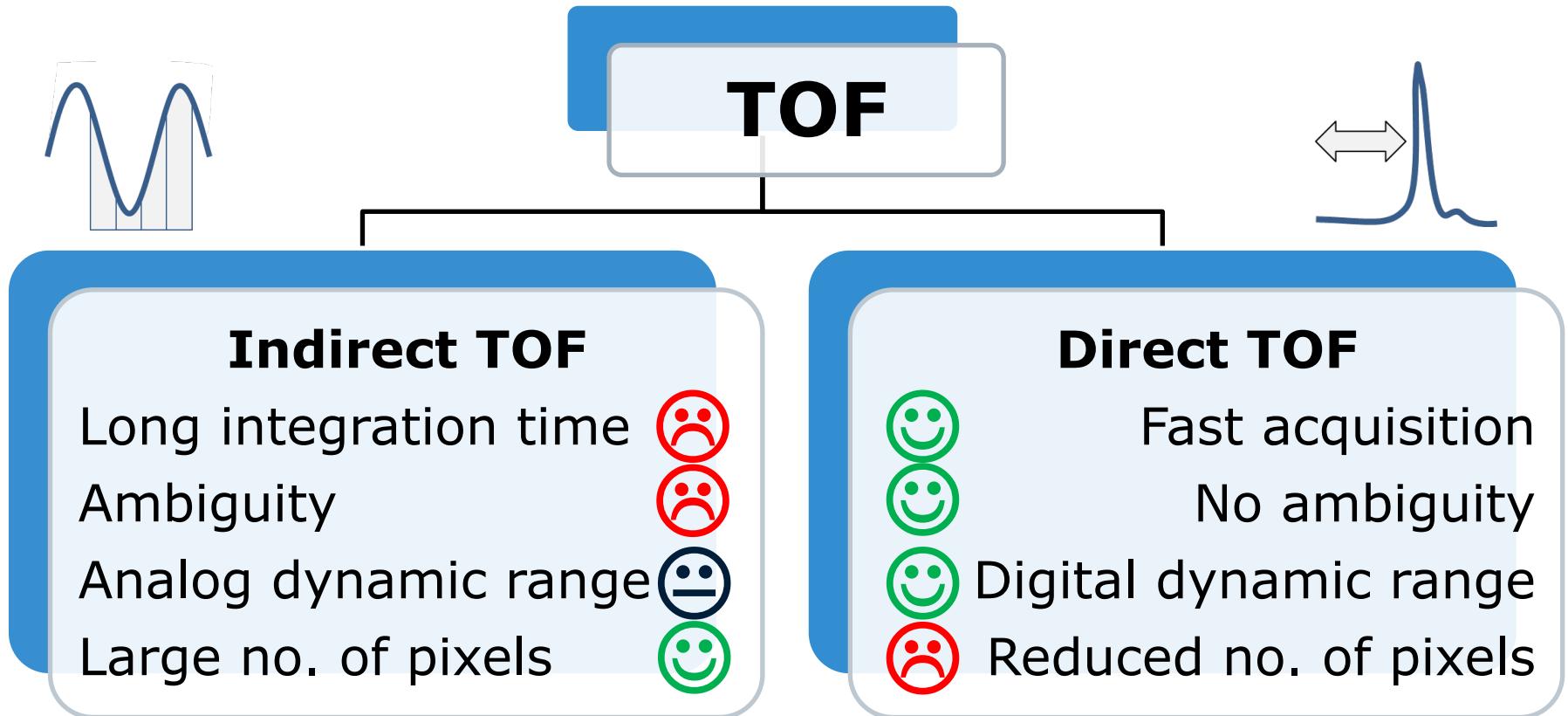


Spacecraft speed:
0.1 m/s - 1.5 m/s

- No artifacts within 1 pixel
 - Fast image acquisition < 2 ms
 - Low frame rate \approx 2 fps
- Enabling post-processing*

Short Acquisition Time

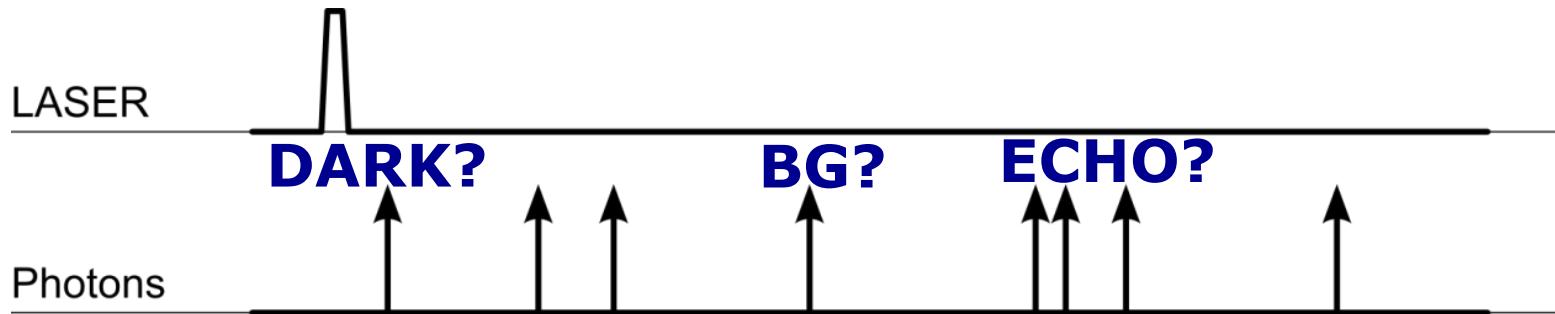
TOF Ranging Techniques



**Challenge: single-photon
detectors are BG sensitive and noisy**

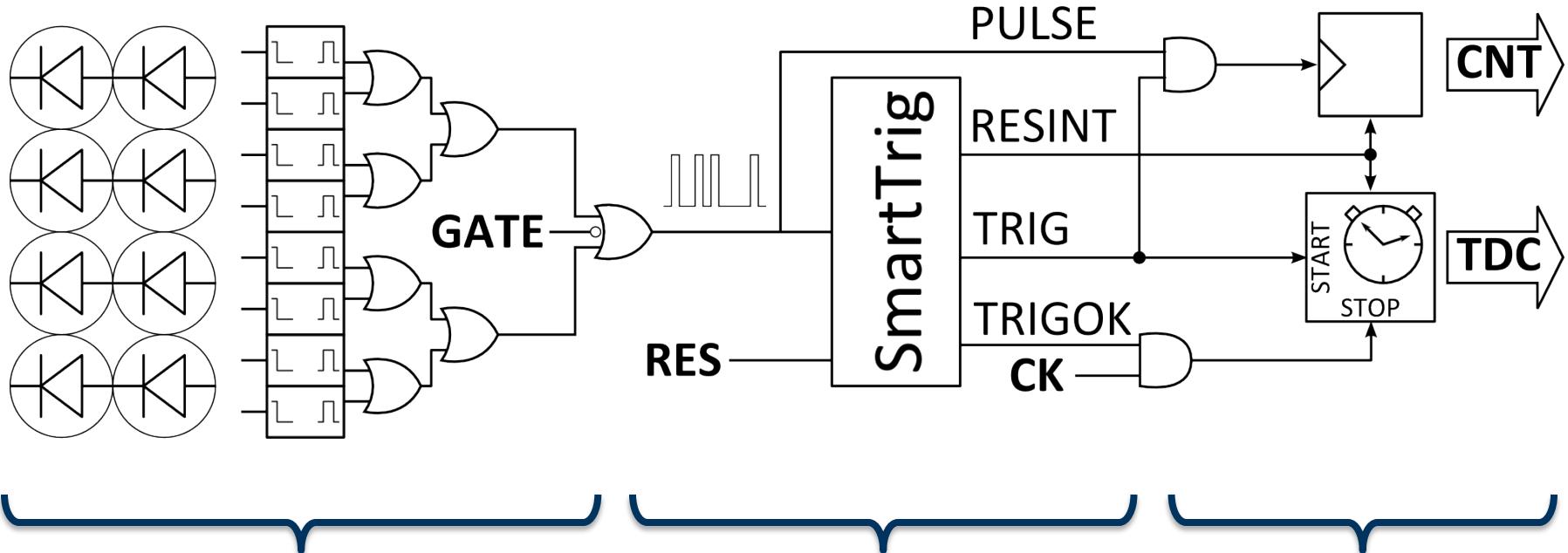
Previous Solutions Limitations

- **Single SPAD + TDC** [Veerappan, ISSCC 2011]
 - Compact pixel (but low FF) ☺
 - First event (dark, bg, echo...): TDC timestamp ☹



- **Multiple SPAD + TDC** [Niclass, JSSC 2014]
 - First relevant event captured ☺
 - Few pixels, imaging through scanning ☹

Pixel Schematic



Digital SiPM

Smaller deadtime

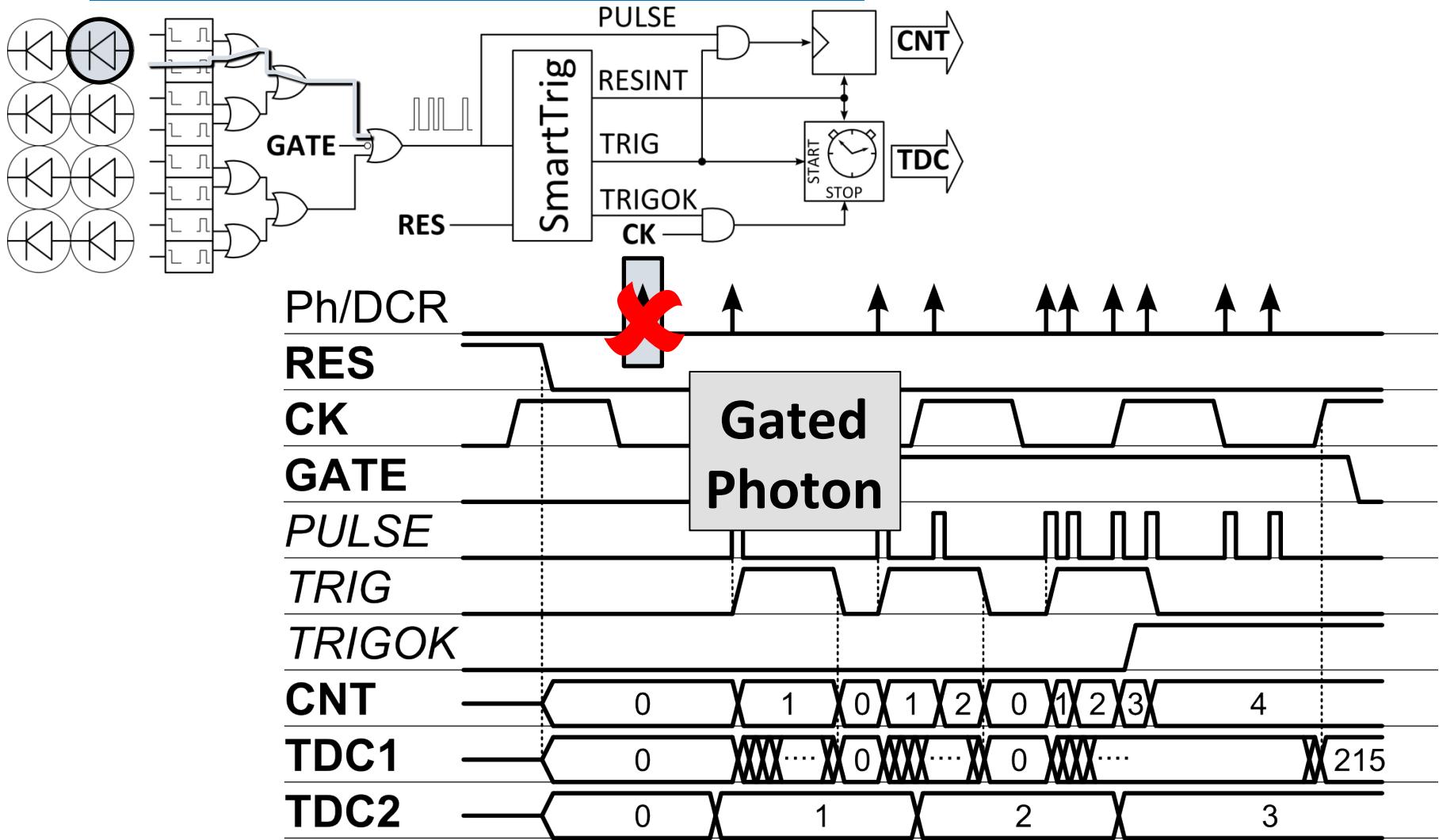
Triggering Logic

Identify echo

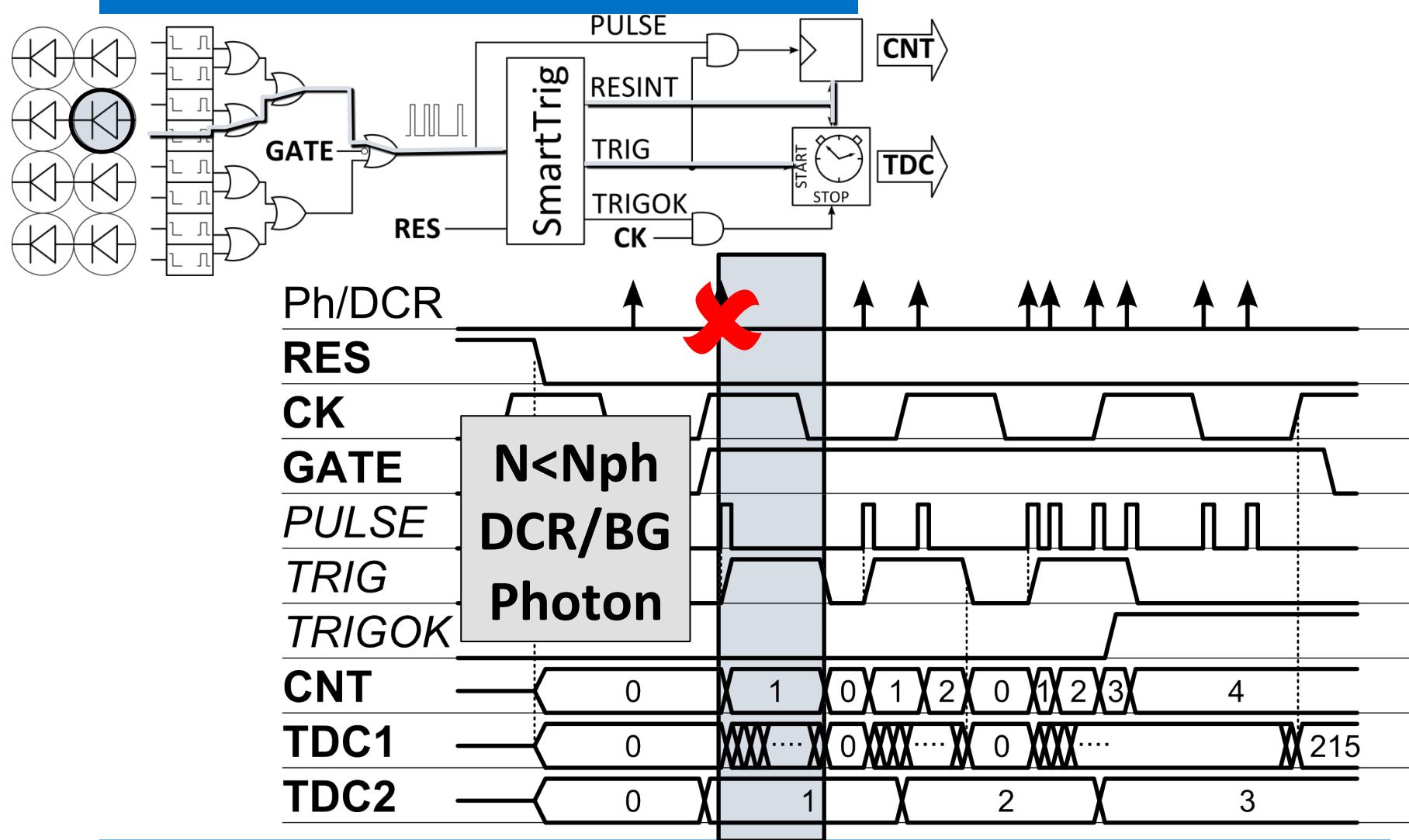
Counter & TDC

Timestamp
and count

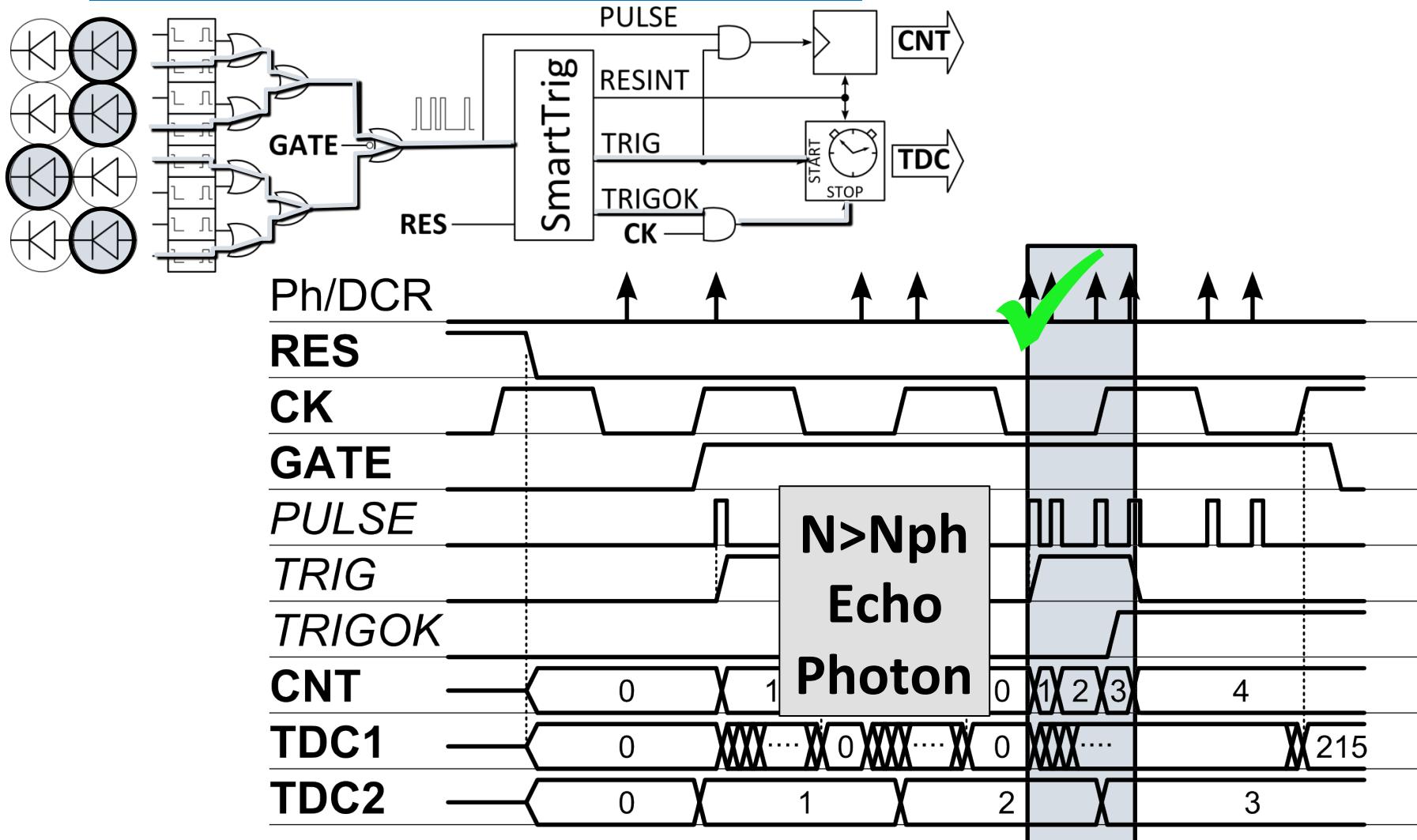
Detailed Operation (1)



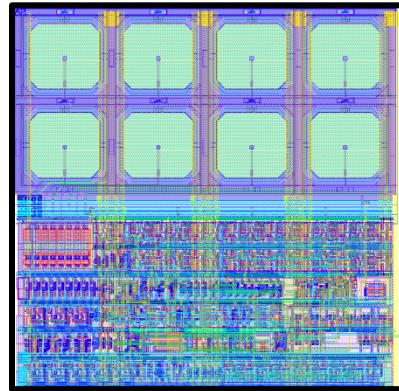
Detailed Operation (2)



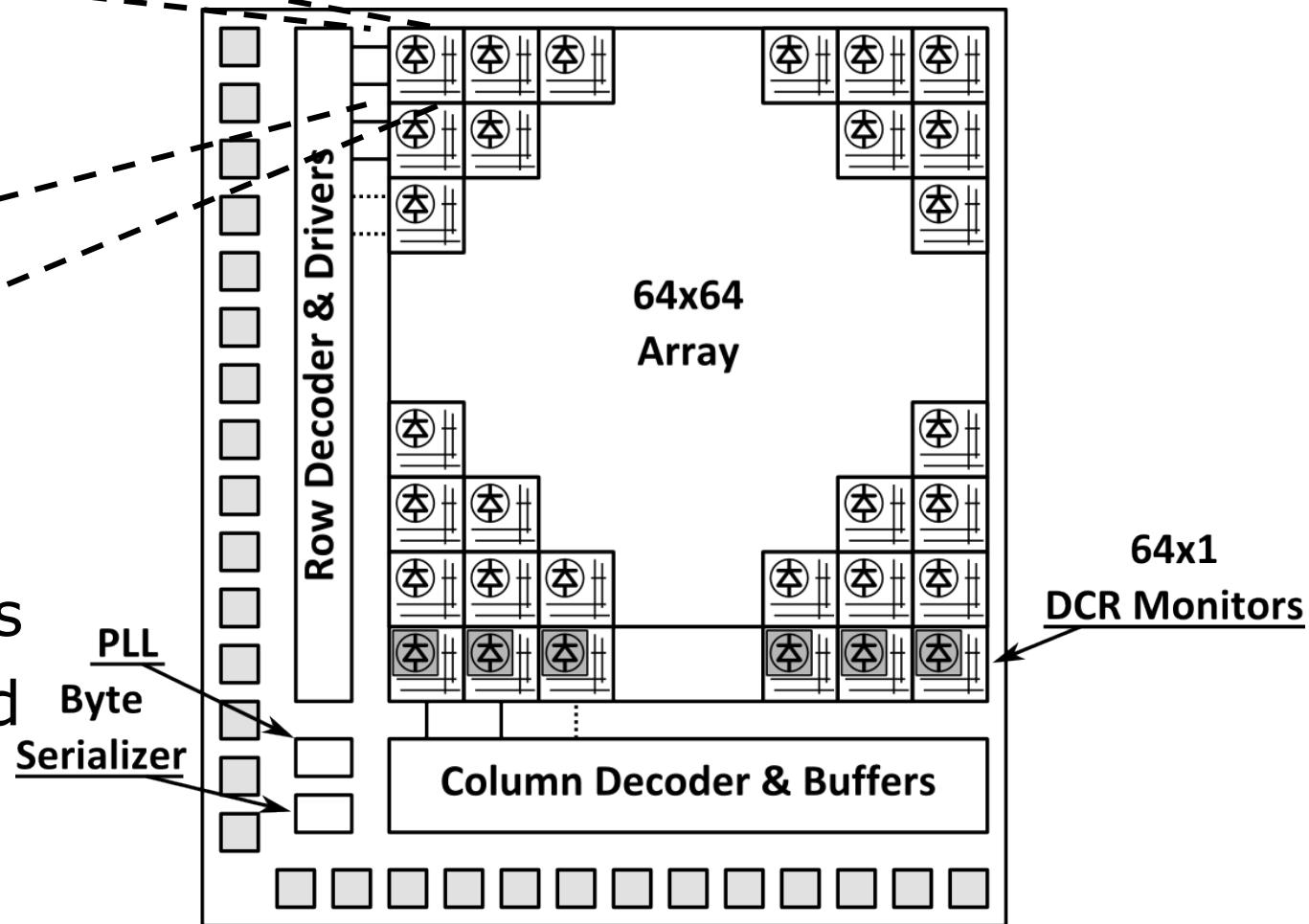
Detailed Operation (3)



Chip Architecture

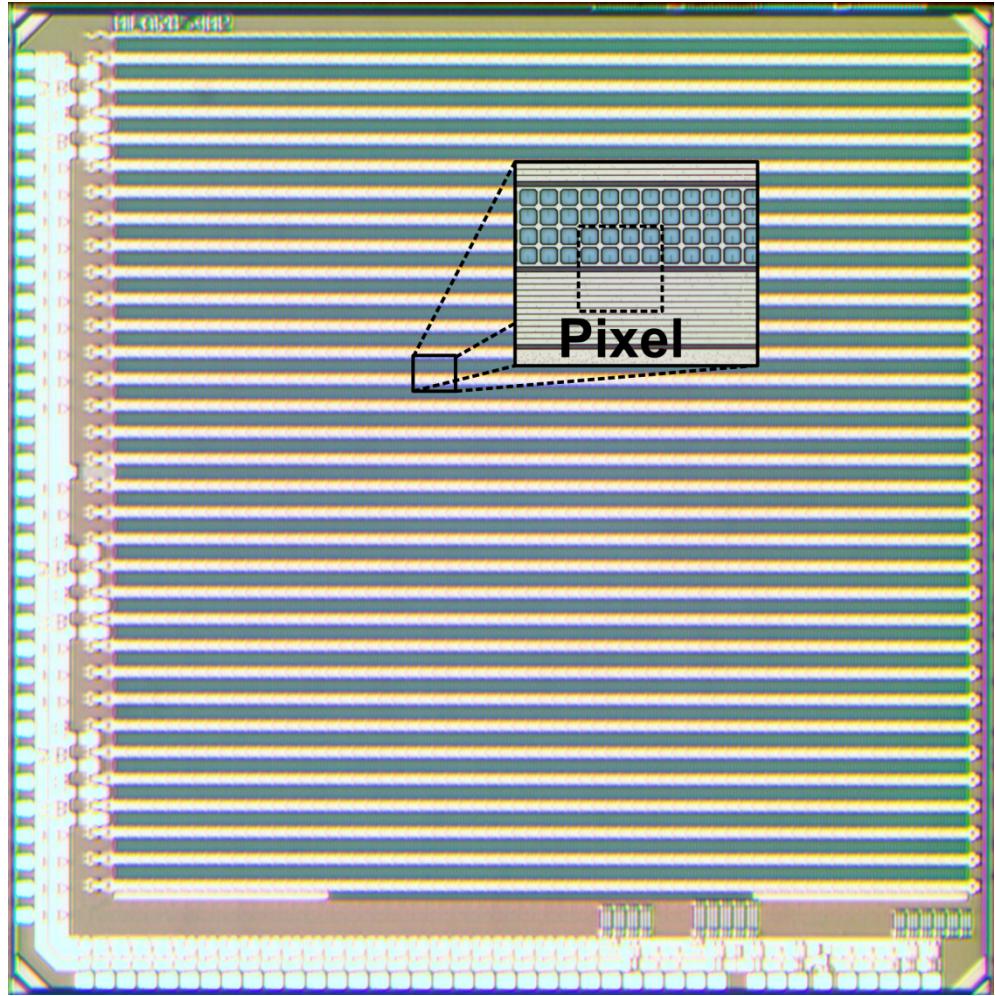


- 60- μm pitch
- 26.5% FF
- 16-bit TDC
- LSB 250ps
- PLL-locked
- 4-bit CNT

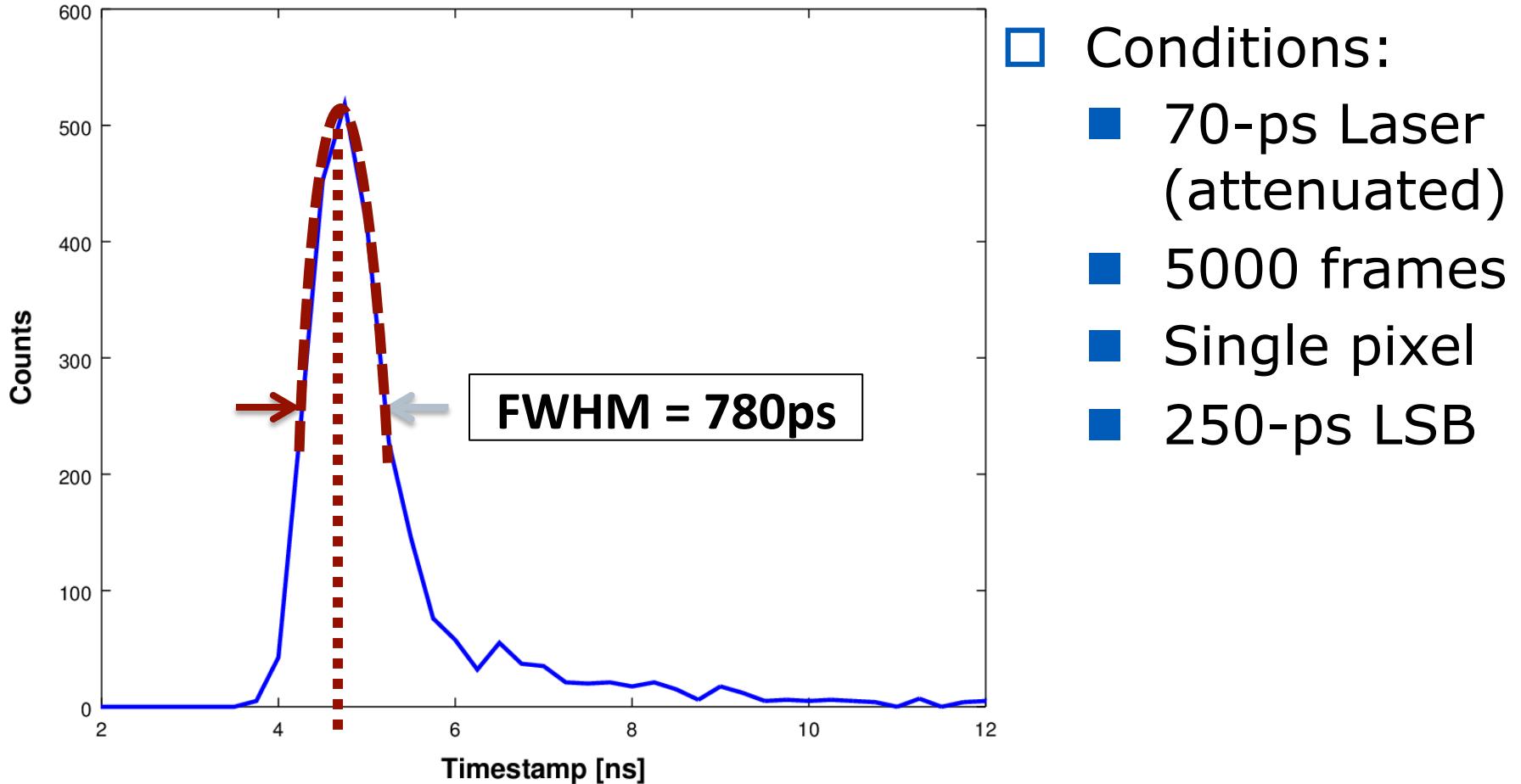


Chip Micrograph

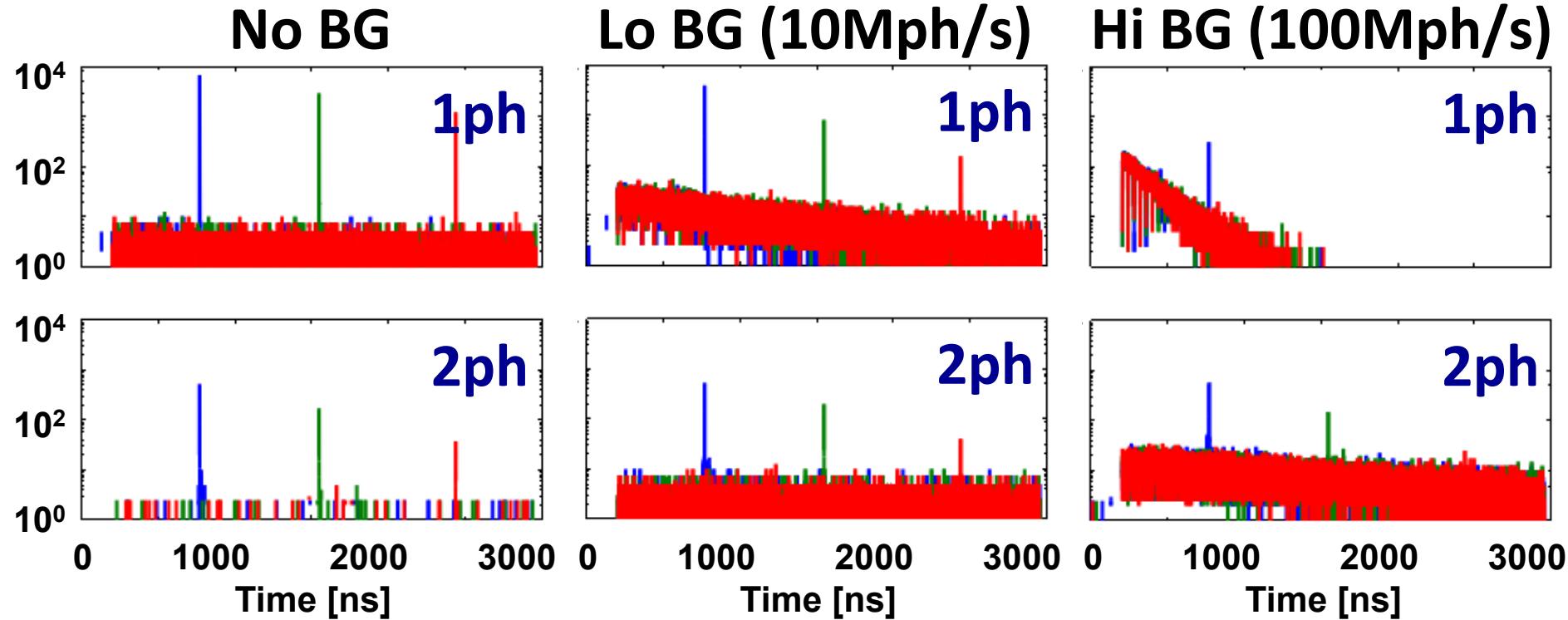
- 150nm CMOS
- $4.4 \times 4.4 \text{ mm}^2$
- $P_{\text{el}} = 47.7 \text{ mW}$
- $P_{\text{SPAD}} = 45.8 \text{ mW}$
- 1920 fps



Timing Resolution



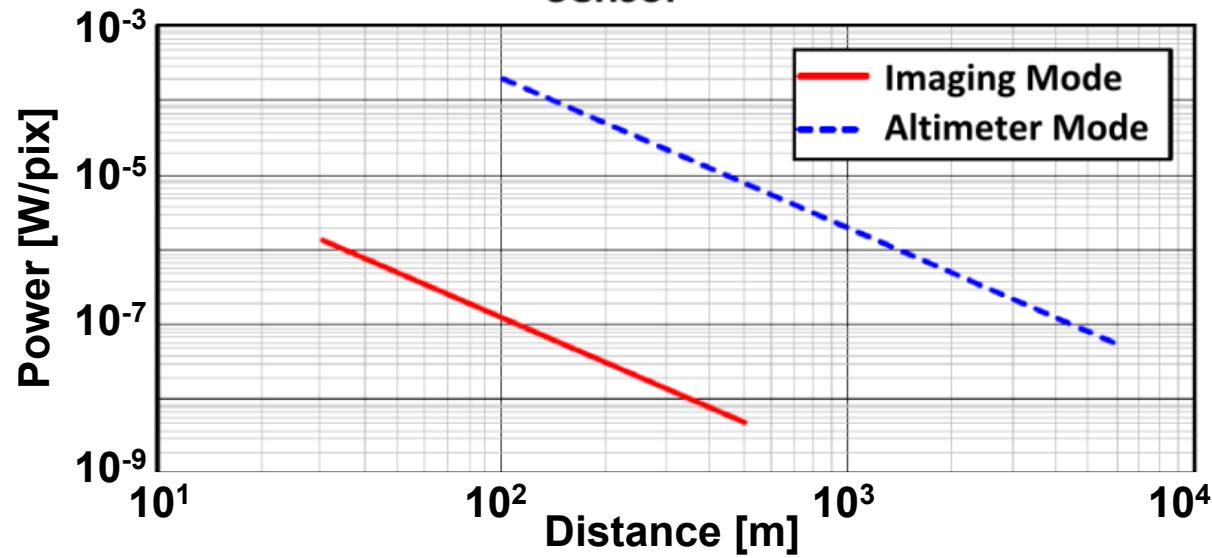
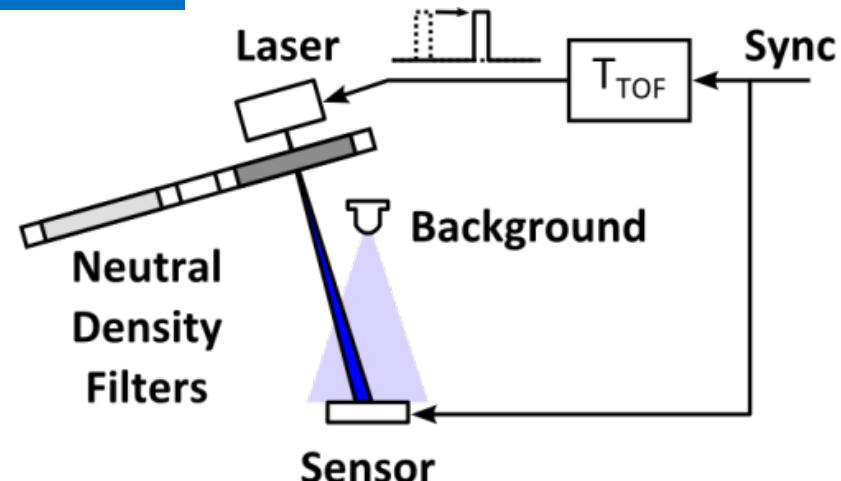
Pile-up With Smart Trigger



- Strong background/DCR is rejected
- Smaller laser peaks

Real Conditions Emulation

- Test vehicle conditions:
 - Laser:
 $P_{pk}=7.5\text{kW}$
 - 50% albedo
 - 2x2 sensors
 - $F\#=0.8$
- 250-pts acq



3D Imaging Example

- <add here CSEM results>

Courtesy of CSEM team (V. Mitev, J. Haesler, C. Pache, T. Herr, A. Pollini)

Conclusions

- FBK is developing CMOS SPAD for different applications
- This talk focuses on TOF sensor:
 - Imager with d-SiPM based pixel
 - Per-pixel multiple photon time correlation
 - Improved dark/BG counts rejection
- Future developments
 - Irradiation tests
 - Larger sensor